Docket No.: 2328-050A PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :

Jian J. CHEN et al.

U.S. Patent Application No.: not yet assigned :

Filed: herewith :

For: INDUCTIVE PLASMA PROCESSOR HAVING COIL WITH PLURAL WINDINGS AND METHOD OF CONTROLLING PLASMA DENSITY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Preliminary to examination of the above-referenced application, please amend the application as follows:

Amendments to the Specification, Title and Abstract—begin on page 2 of this paper

Amendments to Claims — begin on page 5 of this paper

Remarks — begin on page 6 of this paper